



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wayne Glenn Renken  
Title: System and Method for Heating and Cooling Wafer at Accelerated Rates  
Application No.: 10/619,731 Filing Date: July 15, 2003  
Examiner: Unknown Group Art Unit: 1725  
Docket No.: SENS.007US1 Conf. No.: 7022

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 28, 2003

Mary S. Buopju  
Signature

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are not enclosed, since they were either previously submitted in the parent Application No. 10/100,934 or cited by the Examiner in that application.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;

Attorney Docket No.: SENS.007US1

Application No.: 10/619,731

2. a representation that a search has been made a representation that a search has been made, (other than as indicated by any cited document); or

3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

Respectfully submitted,



Gerald P. Parsons  
Attorney for Applicant  
Reg. No. 24,486

October 28, 2003

Date

PARSONS HSUE & DE RUNTZ LLP  
655 Montgomery Street, Suite 1800  
San Francisco, CA 94111  
(415) 318-1160 (main)  
(415) 318-1163 (direct)  
(415) 693-0194 fax

# COPY

OIP E

## Notice of References Cited

OCT 31 2003

Application/Control No.

10/100,934

Applicant(s)/Patent Under  
Reexamination  
RENKEN, WAYNE GLENN

Examiner

Ram N Kackar

Art Unit

1763

Page 1 of 1

### U.S. PATENT DOCUMENTS

		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,965,047	10-1999	Blersch et al.	219/390
	B	US-5,670,218	09-1997	Baek, Yong Ku	427/576
	C	US-6,364,949	04-2002	Or et al.	118/69
	D	US-6,494,955	12-2002	Lei et al.	118/715
	E	US-6,097,005	08-2000	Akimoto, Masami	219/444.1
	F	US-5,872,889	02-1999	Kaltenbrunner et al.	392/418
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.